

### **Inventor Information**

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### **Application Information**

Title Line One::	SCANNING EXPOSURE METHOD AND SYSTEM
Total Drawing Sheets::	28

Docket Number:: 108483

**Prior Foreign Applications**

Foreign Application One::	JP 2000-025661
Filing Date::	February 2, 2000
Country::	Japan
Priority Claimed::	yes
Foreign Application Two::	JP 2000-026630
Filing Date::	February 3, 2000
Country::	Japan
Priority Claimed::	yes